

Notice of References Cited

Application/Control No.

10/594,110

Applicant(s)/Patent Under

Reexamination

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Examiner

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Page 1 of 1

U.S. PATENT DOCUMENTS

*	Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A US-2004/0072060	04-2004	Ukai et al.	429/040
B	US-			
C	US-			
D	US-			
E	US-			
F	US-			
G	US-			
H	US-			
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J	US-			
K	US-			
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FOREIGN PATENT DOCUMENTS

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N					
O					
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T					

NON-PATENT DOCUMENTS

*	Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
U	Buchkremer et al ("Advances in the anode supported planar SOFC technology", Electrochemical Proceedings Volume 97-18, 1997)
V	Stover et al ("Recent developments in anode supported thin film SOFC at research centre julich", Electrochemical Society Proceedings, Volume 99-19, 1999)
W	
X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a))
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